



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 25, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

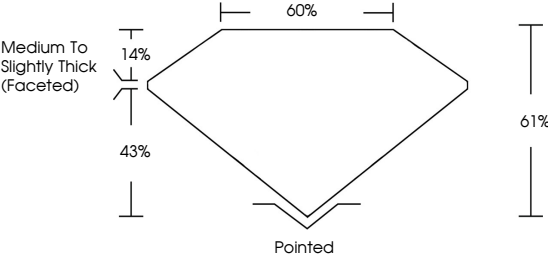
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG831647234

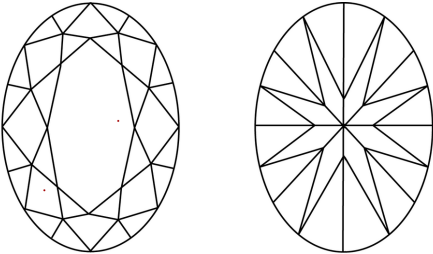
Report verification at igi.org

PROPORTIONS



Medium To Slightly Thick (Faceted)

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D	E	F	G	H	I	J	Faint	Very Light	Light
FL	IF	VVS ¹⁻²	VVS ¹⁻²	SI ¹⁻²	I ¹⁻³				
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included				



Sample Image Used

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LABORATORY GROWN DIAMOND REPORT

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IGI Report No LG831647234

OVAL BRILLIANT

13.93 X 9.83 X 6.00 MM

5.10 CARATS

E

VVS 2

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG831647234

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August 25, 2026

IGI Report No LG831647234

OVAL BRILLIANT

13.93 X 9.83 X 6.00 MM

5.10 CARATS

E

VVS 2

61%

61%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG831647234

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